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520.35237VX3

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: T. KAJI, et al.  
Application No.: 10/052,538  
Filed: January 23, 2002  
For: PLASMA PROCESSING APPARATUS PROCESSING  
METHOD  
Art Unit: 1763  
Examiner: A. M. Crowell

**AMENDMENT**

**MS: AMENDMENTS**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

December 14, 2006

Sir:

In response to the Office Action dated July 14, 2006, the period of response for which extension is requested by the attached Petition for Extension of Time, please amend the above-identified application as listed below and set forth on the following pages:

**Amendments to the Claims and**

**Remarks are included following the amendments.**